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OCT 26 2005

2771-537 CIP

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:)	Docket No.:	ATMI-537 CIP (7496)
Applicants:)	Conf. No.:	9371
Application No.:)	Art Unit:	2818
Date Filed:)	Examiner:	DANG, Phuc T.
Title:)	Customer No.:	25559
SUPERCritical FLUID- ASSISTED DEPOSITION OF MATERIALS ON SEMICONDUCTOR SUBSTRATES)		

FACSIMILE TRANSMISSION CERTIFICATE

ATTN: Examiner Phuc T. DANG

Fax No. (571) 273-8300

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on **October 26, 2005**, to United States Patent and Trademark Office facsimile transmission number (571) 273-8300.

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Number of Pages (including cover)

Tristan A. Fuierer

Tristan A. Fuierer

October 26, 2005

Date

**AMENDMENT RESPONDING TO JULY 26, 2005 OFFICE ACTION
IN UNITED STATES PATENT APPLICATION NO. 10/632,009**

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

This responds to the July 26, 2005 Office Action in the above-identified application.

10/28/2005 TBESHAH1 00000033 10632009

01 FC:1201
02 FC:1202

600.00 OP
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Please amend the claims of the application as set out in the following **Section I (Amendments to the Claims)**.

Remarks addressing the substance of the July 26, 2005 Office Action are set out in the **Section II (Remarks)** hereof.

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